

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 10/340,126
Priority Filing Date January 10, 2003
 Inventor Zhongze Wang
 Assignee Micron Technology, Inc.
Priority Group Art Unit 2812
Priority Examiner Jennifer M. Kennedy
 Attorney Docket No. MI22-2457
 Customer No. 021567
 Title: Wafer Bonding Method of Forming Silicon-on-Insulator Comprising
 Integrated Circuitry

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 10/340,126, filed January 10, 2003. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 12-12-03

By: 
 Mark S. Matkin
 Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2457		PRIORITY SERIAL NO. 10/340,126	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Zhongze Wang			
				PRIORITY FILING DATE January 10, 2003		PRIORITY GROUP ART UNIT 2812	

U.S. PATENT DOCUMENTS							
*Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA	5,021,843	06/1991	Ohmi				
AB	5,849,627	12/1998	Linn et al.				
AC	6,255,731 B1	07/2001	Ohmi et al.				
AD	6,410,938 B1	06/2002	Xiang				
AE	6,433,401 B1	08/2002	Clark et al.				
AF	6,610,615 B1	08/2003	McFadden et al.				
AG	2002/0134503 A1	02/2002	Hussinger et al.				
AH							
AI							

FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
					Yes	No	
AJ							
AK							
AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)		
AM		Bernstein et al., <i>Floating Body Effects</i> , SOI DEVICE ELECTRICAL PROPERTIES 34-53 (pre-August 2001).
AN		
AO		
EXAMINER		DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.